



**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1762**

**PATENT**  
Attorney Docket No. 400113/ASAHINA

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*#111-  
3/2/02*

In re Application of:

HIROAKI SATOH

Application No. 09/271,447

Art Unit: 1762

Filed: March 18, 1999

Examiner: M. Cleveland

For: PROCESS FOR FORMING A  
PATTERN OF FLUORESCENT  
SUBSTRATE AND PLASMA  
DISPLAY PANEL

**RESPONSE TO OFFICE ACTION**

*RECEIVED  
MAR 01 2002  
TC 1700*

Commissioner for Patents  
Box AF  
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated November 27, 2001, please enter the following amendments and consider the following remarks. A page showing the requested changes is attached. This response is accompanied by a Continued Prosecution Application (CPA) Request Transmittal.

**AMENDMENTS**

*IN THE CLAIMS:*

Please replace the indicated claim with:

1. (Amended) A process for forming a pattern of fluorescent substance into the cell of a fluorescent substance display substrate comprising providing inside the cell two separate layers which are (i) a resin composition (A) layer and (ii) a photosensitive resin composition (B) layer,

*CX  
Sub 1  
NO 1*